

U.S. PATENT DOCUMENTS

		Document Number	Date		
*		Country Code-Number-Kind Code	MM-YYYY	Name	Classification
	Α	US-6,531,416	03-2003	Kobayashi et al.	438/795
	В	US-			
	С	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	Н	US-		•	
		US-			
	J	US-			
	К	US-			
	Ĺ	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

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	Z					
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	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter Van Zant; Microchip fabrication: a practical guide to semiconductor processing; 4th ed.; 2000; McGrawHill, New York, pp.63-64
	V	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.